

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant	:	Aggarwal <i>et al.</i>
App. No	:	10/665,693
Filed	:	September 17, 2003
For	:	SYSTEM FOR THE IMPROVED HANDLING OF WAFERS WITHIN A PROCESS TOOL
Examiner	:	Adams, Gregory W.
Art Unit	:	3652
Conf #	:	6237

AMENDMENT ACCOMPANYING REQUEST FOR CONTINUED EXAMINATION**Mail Stop AF**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Dear Sir:

This paper is in response to the Final Office Action mailed September 8, 2006 and the Examiner's Answer mailed September 10, 2007.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 6 of this paper.